



**ELECTRONIC COPY**

LG708571321  
Report verification at igi.org



June 1, 2025  
IGI Report Number **LG708571321**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **ROUND BRILLIANT**  
Measurements **7.15 - 7.23 X 4.44 MM**  
**GRADING RESULTS**  
Carat Weight **1.41 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**  
Cut Grade **IDEAL**

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**GRADING RESULTS**

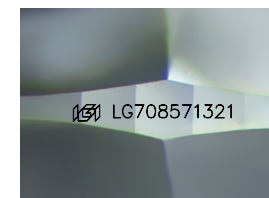
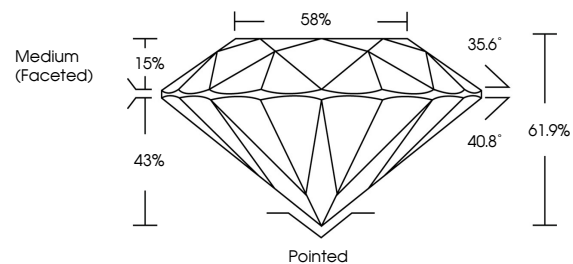
Carat Weight **1.41 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**  
Cut Grade **IDEAL**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG708571321**

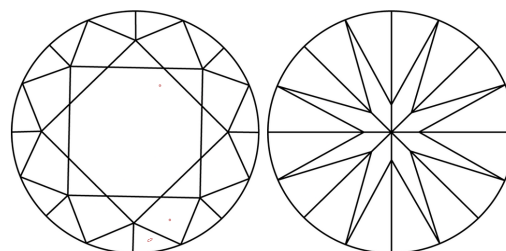
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

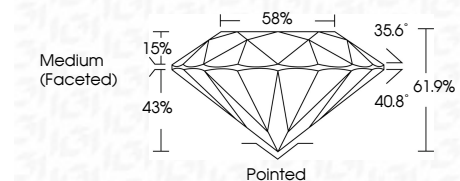
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**ROUND BRILLIANT**  
7.15 - 7.23 X 4.44 MM  
1.41 CARAT  
Color Grade **D**  
Clarity Grade **VS 1**  
Depth **61.9%**  
Table **58%**  
Medium (Faceted)  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG708571321**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa